

**Search Notes**

Application No.

10/720,444

Examiner

Paul D. Kim

Applicant(s)

TAKAHASHI ET AL.

Art Unit

3729

**SEARCHED**

Class	Subclass	Date	Examiner
29	592.1 602.1 603.07 603.12 603.15	4/19/2005	PK
	603.16 603		
360	235.7 235.8		
	236.3 236.5		
	236.6 237		
428	212 216		
	336 426		
	428 432		
	701 702		
438	455-459 69		
	745 753		
369	112.01 300		
	112.05 118		
451	5,41	✓	

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
SAME AS ABOVE		8/11/2005	PK

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Reviewed Parent Application 09/585,428 (US PAT. 6,680,900)	4/19/2005	PK
PLUS Search	4/19/2005	PK
Text Search EAST/NPL (IEEE)	4/20/2005	
Updated Text Search EAST	8/11/2005	PK